

Application No. 09/927,444

Docket No.: 006217 USA/Consilium/Consilium

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

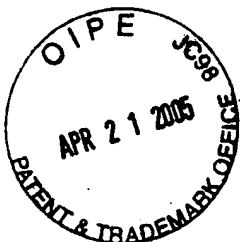
In re Application of

Nicholas A. WARD et al.

Serial No. 09/927,444

Filed: August 13, 2001

For: Dynamic Control Of Wafer Processing Paths In
Semiconductor Manufacturing Processes



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: Group Art Unit: 2125
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: Examiner: Sean P. Shechtman

PETITION FOR EXTENSION OF TIME

Honorable Commissioner for Patents
Alexandria, VA 22313-1450

Sir:


Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated November 3, 2004 for three months, from February 3, 2005 to May 3, 2005.

Please charge the \$1,020.00 fee to cover the cost of the extension to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

Respectfully submitted,
Wilmer Cutler Pickering Hale and Dorr LLP

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Date: April 21, 2005